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Docket No.: 21064/0206584-US0  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Koichi WAGO

Application No.: 10/665,275

Confirmation Number: 5466

Filed: September 22, 2003

Art Unit: 1756

For: ROTARY APERTURED INTERFEROMETRIC  
LITHOGRAPHY (RAIL)

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**PETITION UNDER 37 C.F.R. §1.84**

MS PGPUB Drawings  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Submitted herewith are copies of the originally filed drawings, in color, which include three sets (four sheets, four figures) of color drawings, for filing in the above-identified patent application.

The \$130.00 petition processing fee is included on the attached Fee Transmittal submitted herewith.

Dated: May 3, 2007

Respectfully submitted,

By   
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